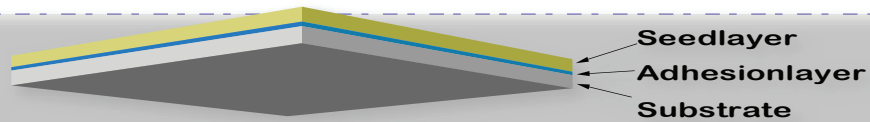


UV-LIGA: Schematic process for Parts

Step 1:
Deposition of
Adhesion / Seedlayer

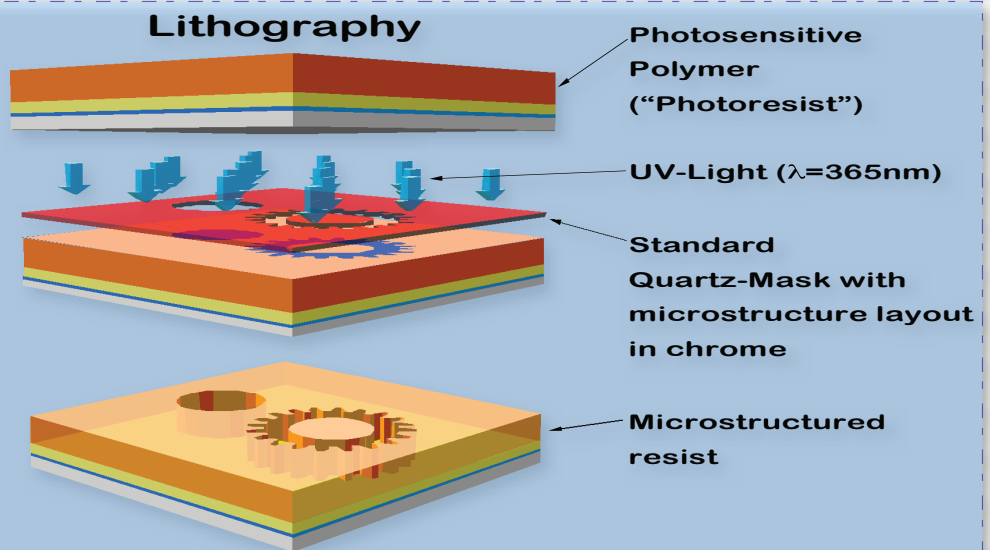


Lithographie

Step 2:
Resist coating

Step 3:
UV-Exposure

Step 4:
Spray development
of exposed resist



Galvanik

Step 5:
Nickel electroforming

Step 6:
Lapping / polishing
upper surface.

Step 7:
Removal of resist and
substrate.

